

PTO/SB/08A (08-03)

Substitute for form 1449A/PTO

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet	1	of	2	Attorney Docket Number	A8443/T52300
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**Complete if Known**

Application Number	10/757,771
Filing Date	January 14, 2004
First Named Inventor	Yuan, Zheng
Art Unit	Not yet known 2923
Examiner Name	Not yet known William M. Branstetter

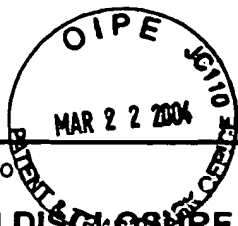
U.S. PATENT DOCUMENTS+					
Examiner Initials*	Cite No.	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number Kind Code <sup>2</sup> (if known)			
QVB	A1	US-5,660,472	08-26-1997	Peuse et al.	X
QVB	A2	US-5,939,763	08-17-1999	Hao et al.	
QVB	A3	US-6,150,286	11-21-2000	Sun et al.	
QVB	A4	US-6,150,209	11-21-2000	Sun et al.	
QVB	A5	US-6,171,901 B1	01-09-2001	Blair et al.	
QVB	A6	US-6,184,155 B1	02-06-2001	Yu et al.	
QVB	A7	US-6,190,973 B1	02-20-2001	Berg et al.	
QVB	A8	US-6,245,689 B1	06-12-2001	Hao et al.	
QVB	A9	US-6,248,628 B1	06-19-2001	Halliyal et al.	
QVB	A10	US-2002/0052128 A1	05-02-2002	Yu et al.	
QVB	A11	US-2002/0102358 A1	08-01-2002	Das et al.	
QVB	A12	US-6,489,254	12-03-2002	Kelkar et al.	
QVB	A13	US-6,512,264 B1	01-28-2003	Ogle, Jr. et al.	
QVB	A14	US-2003/0057432 A1	03-27-2003	Gardner et al.	
QVB	A15	US-6,541,367 B1	04-01-2003	Mandal	
QVB	A16	US-2003/0071304 A1	04-17-2003	Ogle, Jr. et al.	
QVB	A17	US-2003/0073290 A1	04-17-2003	Ramkumar et al.	
QVB	A18	US-2003/0140851 A1	07-31-2003	Lund	X

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)				
MB	B1	TW	479315		03-11-2002			<input type="checkbox"/>
	B2							<input type="checkbox"/>

Examiner Signature	William M. Branstetter	Date Considered	26 SEP 05
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\* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> Kind Codes of U.S. Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

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				Examiner Name	<del>Not yet known</del> William M. Bruneau
Sheet	2	of	2	Attorney Docket Number	A8443/T52300

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
W/B	C1	BAKER, F. et al. "STI TEOS Densification for Furnaces and RTP Tools" 1999 IEEE/SEMI Advanced Semiconductor Manufacturing Conference, 1999, pp. 394-399.	
W/B	C2	Applied Materials Website Printout: "SACVD (Sub-Atmospheric Chemical Vapor Deposition)" from www.appliedmaterials.com/products/sacvd.html, printed 06/20/2003.	
	C3		

Examiner Signature	<i>William M. Bruneau</i>	Date Considered	26 SEP 05
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